## MAXIMUM BEAM CURRENTS OF LIGHT IONS IN RFQS

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The topic of principal limitations for beam intensities in RFQs will be considered. What are the highest currents possible that can be accelerated, when radiofreqency f, electrode voltage V, injection voltage  $U_0$  and minimum aperture  $R_1$  are chosen arbitrarily up to certain limits?

## 1. Limitations

The first and substantial limit is set by sparking and in this context we take Kilpatrick's criterion<sup>1</sup> in the  $approximation^2$ 

$$\frac{V_{2}^{3}}{g^{2}}\left(1-e^{-\frac{9.33+10^{-11}V_{\lambda}}{g^{2}}}\right)e^{-\frac{1.7+10^{-7}g}{V}}=1.8\times10^{18}$$
 (1)

with  $\lambda$  rf wave length, g minimum gap distance, both in meter, voltage V in Volt. According to present opinion<sup>3</sup> sparking is mainly determined by total voltage and gap distance. For any given g, V,  $\lambda$ situation equ. (1) exhibits a voltage, which is said to be 1 Kilpatrick. With regard to RFQ geometry we assume circular rods according to fig. 1 and determine gap distances between points A and B by

$$g = (R_1 + R_2)(\sqrt{2} - 1)$$
 (2)

Variations of electrode distance may occur at other z, resulting differences in Kilpatrick limits are considered small, however. As a second assumption we exclude beam bunches with oplate geometry. In this way we consider RFQs, where the initial cell length  $\beta_0 \lambda/2$  of the adiabatic buncher is equal or larger than the minimum aperture

$$R_1 \le \frac{\beta_0^{\lambda}}{2} = \frac{v_0}{2f}$$
(3)

This does not mean a severe restriction, as it is impossible to design a proper RFQ contrarily. For the initial velocity  $v_0$  we have  $v_0 = \sqrt{2eU_0/m}$ . A possible third limitation that zero current phase advances should not surpass 90° does not play a role in this considerations.

2. Current Formulae The following expressions are used<sup>4.5</sup> at given  $U_0$ . V, f,  $R_1$ ,  $\varphi_s$ ,  $\varphi_s$ ,

$$l_{\max}^{\text{trans}} = \frac{\varepsilon_0 m \omega^3 \overline{a}_t^2 \overline{a}_{1}^2 \sigma_{0t}^2 (1 - \frac{3}{8}q^2)}{e \pi^2 (3 \overline{a}_1 - \overline{a}_t)}$$

$$l_{\max}^{\text{long}} = \frac{\varepsilon_0 m \omega^3 \overline{a}_t \overline{a}_{1}^2 \sigma_{0l}^2}{2e \pi^2}$$
(4)

 $\epsilon_0$  dielectric constant,  $\overline{a}_t$  resp.  $\overline{a}_1$  stand for mean transverse resp. longitudinal envelope radii, synchronous phase  $\varphi_s$  corresponds to velocity v,  $\varphi_{so}$  to v<sub>o</sub>

$$\overline{a}_{t} = \frac{R_{1}}{1 + \frac{q}{2}}$$

$$\overline{a}_{1} = \frac{2v}{\omega} \sqrt{1 - \varphi_{s} \operatorname{ctg}_{\varphi_{s}}}$$
(5)

Zero current phase advances can in good approximation be written

$$\frac{\sigma_{ot}^{2}}{\pi^{2}} = \frac{a + \frac{q}{2}^{2}}{1 - \frac{3}{8}q^{2}}$$

$$\frac{\sigma_{o1}^{2}}{\pi^{2}} = -2a$$
(6)

with parameters a and q

$$a = \frac{eVA \sin g}{2mv^2}$$

$$q = \frac{2eCV}{m\omega^2 R_1}$$
(7)

Velocity v at the end, when the bunch length is kept constant along the buncher, with  $\varphi_s$  is related to input velocity v<sub>o</sub> with  $\varphi_{so}$  according to

$$\mathbf{v} = \mathbf{v}_{o} \sqrt{\frac{1 - \varphi_{so} ct \mathbf{g} \varphi_{so}}{1 - \varphi_{s} ct \mathbf{g} \varphi_{s}}}$$
(8)

We assume  $\varphi_{so} = 75^{\circ}$ ,  $\varphi_{s} = 30^{\circ}$ ,  $v = v_{o} \cdot 2.64$  throughout in this paper. A and C apply to the well known two term RFQ potential

$$A = \frac{m^2 - 1}{I_o(\frac{\omega}{v} m R_1) + m^2 I_o(\frac{\omega}{v} R_1)}$$

$$C = I - AI_o(\frac{\omega}{v} R_1)$$
(9)

(I modified Bessel function of zero order)

State of affairs is illustrated in fig. 2. Point P, where  $I^{opt} = I^{long}_{max} = I^{trans}_{max}$ , corresponds to optimum RFQ parameters

$$q_{opt} = \sqrt{P^2 + O} - P$$

$$a_{opt} = \frac{\frac{\alpha^2}{2} q_{opt} - \chi}{K}$$
(7b)

with abbreviations

$$P = \frac{\alpha^2 - \chi}{\frac{2R_1K}{3\overline{a}_1} + \alpha^2}, \quad O = \frac{4\chi}{\frac{2R_1K}{3\overline{a}_1} + \alpha^2}, \quad K = \frac{2I_o(\alpha)}{\sin\varphi_s}$$
(10)

$$\chi = \frac{eV}{mv^2} \quad \left( = \frac{1}{2 \cdot 2.64^2} \cdot \frac{V}{U_o} \approx 0.072 \frac{V}{U_o} \right) \quad (11)$$

$$\alpha = \frac{\omega}{v} R_1 \quad (= 1.1919 \text{ for maximum } R_1 = \frac{v_0}{2f}) (12)$$

Evidently from adds given above relevant degrees of freedom reduce to proper choice of V/U<sub>o</sub> resp.  $\chi$  (11) and  $\alpha$  (12). Since it is our aim to estimate maximum beam currents, only  $I_{\alpha}^{opt}$  is of interest and it should be emphasized that they scale with  $\alpha$  and  $\chi$ . On this base fig. 3 shows calculations of  $I_0^{opt}$ ,  $\sigma_{ot}$  and m with  $\alpha$  = 1.1919, amu = 1 protons,  $U_0$  = 100 kV. Denoting these  $I_{\alpha}^{opt}(\chi,\alpha)$  currents of other ions (amu > 1) and different injection voltage scale according to

$$I^{opt}(\alpha, \chi) = \sqrt{\left(\frac{U_o[kV]}{100}\right)^3 \frac{1}{amu} \cdot I_o^{opt}(\alpha, \chi)}$$
 (4a)

Since apertures turn out large with  $\alpha = 1.1919$  for low frequencies (12) and in order to increase  $\sigma_{ot}$  (6) by a larger  $q_{opt}$  (7b) fig. 4 displays situations, when apertures are reduced by a factor of 2. We state, however, that this causes a significant sacrifice of current I opt. Variation of injection voltage or ion mass changes velocities, so according to (12)  $R_1$  (and  $R_2$ ) has to match  $\alpha$ 's. This of course leads to different gaps (2), electrode voltages (11) and Kilpatrick factors (1). Figs. 5 and 6 illustrate calculations, where assumed modulation 2.4 corresponds to  $\chi = 0.918$  for  $\alpha = 1.1919$  and  $\chi = 0.344$ for  $\alpha = 0.5959$  as seen from figs. 3 and 4. Table I comprehends RFQ examples for highest possible beam currents and their feasibility of practical present ion disregarding source realization, limitations. Summarizing efforts, we can say: Maximum beam current is obtained with maximum Table 1 R, lobt KPT Comments

α	amu	f [MHz]	$\begin{bmatrix} U \\ kV \end{bmatrix}$	V [kV]	R <sub>1</sub> [cm]	I <sup>opt</sup> [A]	KPT	Comments
1.1919	1	27	25	320	4.06	0.544	0.76	feasible
٠		54	25	320	2.03	0.544	1.26	feasible
•	•	108	25	320	1.015	0.544	2.02	high KPT
•	-	13.5	100	1280	16.24	4.35	0.95	high V and R
-	-	27	100	1280	8.12	4.35	1.6	doubtful KPT
0.5956	-	13.5	100	480	8.12	1.22	0.65	feasible
-	-	27	100	480	4.06	1.22	1.10	feasible
•	-	54	100	480	2.03	1.22	1.83	doubtful KPT
•	-	13.5	200	933	11.48	3.44	0.95	large R <sub>1</sub>
٠	+	27	200	933	5.74	3.44	1.61	doubtful KPT
1.1919	2	13.5	100	1200	11.48	2.87	1.24	high V and R <sub>1</sub>
0.5959	_	27	100	467	2.87	0.86	1.5	feasible
0.5959		13.5	200	933	8.12	2.43	1.29	feasible

maximum advance and transverse phase modulation. Scaling laws (11) and (12) favour low frequencies and not too high injection voltages. Excamples exhibit protons up to 4 amps and deuterons up to 2 amps. Because of demands on RF powers, beam powers, electrode voltages, low frequencies etc. comments should be considered speculatively.

## References

- 1. W.D. Kilpatrick, UCRL-2321, Univ. of California, Berkeley 1952
- 2. K. Mittag, KFK 2555, Kern forschungszentrum Karlsruhe 1978
- 3. A. Gerhard et al., this conference
- 4. P. Junior, Part. Acc. 13 (1983) p. 231
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Fig. 1 Four rod geometry with modulation  $m = R_2/R_1$ a) x-y intersection at z = 0



b) x-z intersection at y = 0



Current limits from equ. (4) versus zero current transverse phase advance



Fig. 3 Current  $I^{opt}$ , modulation m and phase advance  $\sigma_{ot}$  versus normalized voltage for normalized aperture  $\alpha = 1.1919$ , protons, injection voltage 100 kV



Fig. 4 Same as in fig. 3, but normalized aperture  $\alpha = 0.5959$ 



Fig. 5 Kilpatrick factors versus frequency for modulation m = 2.46 and normalized aperture  $\alpha$  = 1.1919



Fig. 6 Kilpatrick factors versus frequency for modulation m = 2.4 and normalized aperture  $\alpha$  = 0.5959